

Receipt date: 11/20/2006

10586566 GAU: 1774

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|   | Filing Date            |                     |          |
|   | First Named Inventor   | Yellen and Friedman |          |
|   | Art Unit               | None                |          |
|   | Examiner Name          | Not Yet Assigned    |          |
|   | Attorney Docket Number | DRE0175US.NP        |          |

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|                   | 3       | 6415821       |                        | 2006-11-17 | Kamholz et al.                                  |  |        |
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|  | Examiner Name          | Not Yet Assigned    |          |                      |
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| /AJJ/<br> | 8  | Yellen et al., "Programmable Assembly of Heterogeneous Colloidal Particle Arrays", Adv. Mater. 2004 16(2):111-115  | <input checked="" type="checkbox"/> |
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| Examiner Signature | /Andrew Janca/ | Date Considered | 12/23/2010 |
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A signature of the applicant or representative is required in accordance with CFR 1.33, 10.18. Please see CFR 1.4(d) for the form of the signature.

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|------------|---------------------------|---------------------|------------|
| Signature  | ///Kathleen A. Tyrrell/// | Date (YYYY-MM-DD)   | 2006-11-20 |
| Name/Print | Kathleen A. Tyrrell       | Registration Number | 38,350     |

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